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CASE SE/2-22853/A/PCT

CERTIFICATE OF MAILING

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12/7/06  
Date

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE PCT NATIONAL STAGE APPLICATION OF

Group Art Unit: 1755

PATRICE BUJARD ET AL

Examiner: HAILEY, PATRICIA L.

INTERNATIONAL APPLICATION NO. PCT/EP 03/50229

FILED: JUNE 16, 2003

FOR: PLANE-PARALLEL STRUCTURES OF

SILICON/SILICON OXIDE

U.S. APPLICATION NO: 10/517,283

35 USC 371 DATE: DECEMBER 8, 2004

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

RESPONSE

Sir:

In response to the Office Action dated September 12, 2006, the following remarks and Declarations are respectfully submitted for entry and consideration. The Action set a 3 month shortened statutory period for response, making this paper due December 12, 2006. This reply is timely filed and no petition for an extension of time to respond is required.

The Commissioner is hereby authorized to charge any necessary fee or credit any overpayment to Deposit Account No. 03-1935.